

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 10/039,456  
Priority Filing Date ..... December 31, 2001  
Inventor ..... Ying Huang et al.  
Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2829  
Priority Examiner ..... S.B. Geyer  
Attorney's Docket No. .... MI22-2347  
Title: An Improved Method, Structure and Process Flow to Reduce Line-Line  
Capacitance with Low-K Material

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
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Sir:

This is a preliminary amendment accompanying a Request for Continuation Application for the above-entitled patent application. Prior to examining the application, please enter the following amendments.

**AMENDMENTS**

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.